

**IN THE CLAIMS:**

1           1.       (Amended) A method of producing a PDP, the method comprising:  
2                   a first step of forming a front cover plate by forming a first electrode and a  
3 dielectric glass layer on a front glass substrate then forming a protecting layer of an alkaline  
4 earth oxide [with one] of [(100)-face orientation and] (110)-face orientation on the dielectric  
5 glass layer; and  
6                   a second step of forming a back plate by forming a second electrode and a  
7 fluorescent substance layer on a back glass substrate then bonding the front cover plate, on which  
8 the protecting layer has been formed, with the back plate, and charging a gas medium into a  
9 plurality of discharge spaces which are formed between the front cover plate and the back plate,  
10 the front cover plate and the back plate facing to each other.

1           2.       (Original) The method of producing a PDP of claim 1, wherein  
2                   in the first step, the protecting layer is formed with one of a thermal Chemical  
3 Vapor Deposition method and a plasma Chemical Vapor Deposition method by using an alkaline  
4 earth organometallic compound and oxygen.

1           3.       (Original) The method of producing a PDP of claim 2, wherein  
2                   the alkaline earth organometallic compound used in the first step is one of an  
3 alkaline earth metal chelate compound and an alkaline earth cyclopentadienyl compound.

1           4.       (Original) The method of producing a PDP of claim 3, wherein  
2                   the alkaline earth organometallic compound used in the first step is one of  
3  $M(C_{11}H_{19}O_2)_2$ ,  $M(C_5H_7O_2)_2$ ,  $M(C_5H_5F_3O_2)_2$ , and  $M(C_5H_5)_2$ , wherein M represents one of  
4 magnesium, beryllium, calcium, strontium, and barium.

1           5.       (Amended) A method of producing a plasma display panel having a plurality of  
2 discharge space cells with a front substrate and a rear substrate and walls separating each cell,  
3 each discharge space is addressable by display electrodes to cause the cell to emit light  
4 comprising:

5                 depositing a protective layer of an alkaline earth oxide having [one of a (100)  
6 crystal face orientation and] a (110) crystal face orientation extending across a top surface of  
7 each cell; and

8                 charging each cell with a discharge gas.

1           6.       (Original) The plasma display panel method of claim 5 wherein each cell is  
2 pressurized to pressure of approximately 500 to 760 Torrs.

1           7.       (Original) The plasma display panel method of claim 6 wherein each cell is  
2 charged with an xenon discharge gas between 10% by volume to approximately 100% by  
3 volume.

1           8.       (Original) The plasma display panel method of claim 7 wherein one of argon,  
2 krypton, helium and neon is mixed with the xenon.

1           9.       (Original) The plasma display panel method of claim 7 wherein one of argon and  
2 krypton is mixed with the xenon in sufficient volume to provide ultraviolet light emission at a  
3 wavelength of 173 nm.

1           10.      (Original) The plasma display panel method of claim 7 wherein two additional  
2 discharge gases within the range of 10% to 50% by volume are mixed with the xenon.

1           11.     (Original) The plasma display panel method of claim 6 wherein a distance  
2     between adjacent display electrodes in the same plane is no greater than 0.1 mm.

1           12.     (Original) The plasma display panel method of claim 5 wherein the protective  
2     layer is selected from a group consisting of MgO, BeO, CaO, SrO and BaO.

1           13.     (Original) The plasma display panel method of claim 5 wherein the protective  
2     layer is magnesium oxide with a crystal face orientation of (110).

1           14.     (Amended) The plasma display panel method of claim 5, wherein the first  
2     substrate includes a dielectric glass layer and the dielectric glass layer is heated to a temperature  
3     between 350° C[.] to 400° C[.] during the depositing of the protective layer by a thermal  
4     chemical vapor deposition.

1           15.     (Amended) The plasma display panel method of claim 5, wherein the front  
2     substrate includes a dielectric glass layer and the dielectric glass layer is heated to a temperature  
3     between 250° C[.] to 300° C[.] during the depositing of the protective layer by a plasma  
4     enhanced chemical vapor deposition.

1           16.     (Original) The plasma display panel method of claim 5, wherein the front  
2     substrate includes an upper glass plate and a lower dielectric glass layer, and display electrodes  
3     are formed from depositing a conductive paste on the upper glass plate, the paste is then baked to  
4     harden it and subsequently is sandwiched with the lower dielectric glass layer.

1           17.     (Original) The plasma display panel method of claim 5, wherein the protective  
2 layer is deposited by transferring a paste of the alkaline earth oxide to the front substrate and  
3 baking it.

1           18.     (Original) The plasma display panel method of claim 17, wherein the paste is a  
2 magnesium salt with a plate-shaped crystal structure.

1           19.     (Original) The plasma display panel method of claim 18, wherein the paste is  
2 magnesium oxalate formed by dissolving ammonium oxalate in a magnesium chloride aqueous  
3 solution and heating it to form the plate-shaped crystal structure.

1           20.     (Original) The plasma display panel method of claim 5, wherein the depositing of  
2 the protective layer is made by evaporating the alkaline earth oxide with an ion/electron beam in  
3 a vacuum.

1           21.     (Original) A method of producing a plasma display panel having a plurality of  
2 discharge space cells, each discharge space cell is addressable by display electrodes to cause the  
3 cells to emit light, comprising:

4                 depositing a protective layer of an alkaline earth compound selected from the  
5 group consisting of  $M(C_{11}H_{19}O_2)_2$ ,  $M(C_5H_7O_2)_2$ ,  $M(C_5H_5F_3O_2)_2$ , and  $M(C_5H_5)_2$ , wherein M  
6 represents one of magnesium, beryllium, calcium, strontium, and barium, the protective layer  
7 having one of a (100) crystal-face orientation and a (110) crystal-face orientation extending  
8 across a surface of each cell; and

9                 charging each cell with a discharge gas.

1        22.    (Original) The plasma display method of claim 21, wherein the protective layer is  
2 deposited by one of a thermal chemical vapor deposition step and a plasma enhanced chemical  
3 vapor deposition step.

1        23.    (Original) The plasma display method of claim 22, wherein the discharge gas  
2 includes at least 10% by volume Xe and is at a pressure of at least 500 Torr.

1        24.    (Original) The plasma display method of claim 23, wherein the discharge gas  
2 includes one of Ar and Kr.

1        25.    (Amended) The plasma display method of claim 23 wherein the discharge gas is  
2 selected from a group consisting of [Ar-He-Xe,] Ar-He-Xe, Kr-Ne-Xe, and Kr-He-Xe and the  
3 amount of Kr, Ar, He, or Ne should be in the range of 10% to 50% by volume.

1        26.    (Original) The plasma display method of claim 23, wherein the alkaline earth  
2 compound is selected from the group consisting of magnesium dipivaloyl methane, magnesium  
3 acetylacetone, magnesium trifluoroacetylacetone, and cyclopentadienyl.

1        27.    (Original) A method of producing a plasma display panel having a plurality of  
2 discharge space cells, each discharge space cell is addressable by display electrodes to cause the  
3 cell to emit light, comprising:

4            depositing a protective layer selected from the group consisting of magnesium  
5 dipivaloyl methane, magnesium acetylacetone, magnesium trifluoroacetylacetone, and  
6 cyclopentadienyl magnesium across a surface of each cell to provide one of a (100) crystal-face  
7 orientation and a (110) crystal-face orientation; and

8 charging each cell with a discharge gas including at least 10% by volume Xe at a  
9 pressure of at least 500 Torr.

1 28. (Amended) A method of producing a PDP, the method comprising:  
2 a first step of forming a front cover plate by forming a first electrode and a  
3 dielectric layer on a front glass substrate, then forming a protecting layer of an alkaline earth  
4 oxide with (110)-face orientation on the dielectric layer; and  
5 a second step of forming a back plate by forming a second electrode and a  
6 fluorescent substance layer on a back glass substrate;  
7 a third step of bonding the front cover plate with the back elate and introducing a  
8 gas medium into a plurality of discharge spaces which are formed between the front cover plate  
9 and the back plate, the front cover plate and the back plate facing to each other.

1 29. (Original) The method of Claim 28, wherein  
2 in the first step, the protecting layer is formed with one of a thermal Chemical  
3 Vapor Deposition method and a plasma Chemical Vapor Deposition method by using an alkaline  
4 earth organometallic compound and oxygen.

1 30. (Original) The method of producing a PDP of Claim 29, wherein  
2 the alkaline earth organometallic compound used in the first step is one of an  
3 alkaline earth metal chelate compound and an alkaline earth cyclopentadienyl compound.

1        31. (Amended) The method of producing a PDP of Claim 30, wherein  
2        The alkaline earth organometallic compound used in the first step is one of  
3         $M(C_{11}H_{19}O_2)_2$ ,  $M(C_5H_7O_2)_2$ ,  $M(C_5H_5F_3O_2)_2$ , and  $M(C_5H_5)_2$ , wherein M represents one of  
4        magnesium, beryllium, calcium, strontium, and barium.

1        32. (Amended) A method of producing a plasma display panel having plurality of  
2        discharge space cells comprising the steps of:  
3        depositing a protective layer of an alkaline earth oxide having a (110) crystal face  
4        orientation on a surface of a dielectric layer of a substrate;  
5        and  
6        introducing a discharge gas into each cell.

1        33. (Original) The plasma display panel method of Claim 32, wherein each cell is  
2        pressurized to a pressure of approximately 500 to 750 Torrs.

1        34. (Original) The plasma display panel method of Claim 33, wherein each cell is  
2        charged with a xenon discharge gas between 10% volume to approximately 100% by volume.

1        35. (Original) The plasma display panel method of Claim 34, wherein one of argon,  
2        krypton, helium, and neon is mixed with the xenon.

1        36. (Original) The plasma display panel method of Claim 34, wherein one of argon  
2        and krypton is mixed with the xenon in sufficient volume to provide ultraviolet light emission at  
3        a wavelength of 173 nm.

1        37. (Original) The plasma display panel method of Claim 34, wherein two additional  
2 discharge gases within the range of 10% to 50% by volume are mixed with the xenon.

1        38. (Original) The plasma display panel method of Claim 33, wherein a distance  
2 between adjacent display electrodes in the same plane is no greater than 0.1 mm.

1        39. (Original) The plasma display panel method of Claim 32, wherein the protective  
2 layer is selected from a group consisting of MgO, BeO, CaO, SrO, and BaO.

1        40. (Original) The plasma display panel method of Claim 32, wherein the protective  
2 layer is magnesium oxide with a crystal face orientation of (110).

1        41. (Original) The plasma display panel method of Claim 32, wherein the first  
2 substrate includes a dielectric layer and the dielectric layer is heated to a temperature between  
3 350°C to 400°C during the depositing of the protective layer by a thermal chemical vapor  
4 deposition.

1        42. (Original) The plasma display panel method of Claim 32, wherein the front  
2 substrate includes a dielectric layer and the dielectric layer is heated to a temperature between  
3 250°C to 300°C during the depositing of the protective layer by a plasma chemical vapor  
4 deposition.

1        43. (Original) The plasma display panel method of Claim 32, wherein the front  
2 substrate includes a glass plate and display electrodes are formed by depositing a conductive  
3 paste on the glass plate, the paste is then baked to be hardened and the display electrodes  
4 subsequently are sandwiched between the glass plate and the dielectric layer.



1        44. (Original) The plasma display panel method of Claim 32, wherein the protective  
2 layer is deposited by transferring a paste of the alkaline earth oxide to the front substrate and  
3 baking it.

1        45. (Original) The plasma display panel method of Claim 44, wherein the paste is  
2 magnesium salt with a plate-shaped crystal structure.

1        46. (Original) The plasma display panel method of Claim 45, wherein the paste is  
2 magnesium oxalate formed by dissolving ammonium oxalate in a magnesium chloride aqueous  
3 solution and heating it to form the plate-shaped crystal structure.

1        47. (Original) The plasma display panel method of Claim 32, wherein the depositing  
2 of the protective layer is made by evaporating the alkaline earth oxide with an ion/electron beam  
3 in a vacuum.

1        48. (Original) A method of producing a plasma display panel having a plurality of  
2 discharge space cells comprising:  
3        depositing a protective layer of an alkaline earth compound selected from the  
4 group consisting of  $M(C_{11}H_{19}O_2)_2$ ,  $M(C_5H_7O_2)_2$ ,  $M(C_5H_5F_3O_2)_2$ , and  $M(C_5H_5)_2$ , wherein M  
5 represents one of magnesium, beryllium, calcium, strontium, and barium, the protective layer  
6 having one of a (100) crystal-face orientation and a (110) crystal-face orientation extending  
7 across a surface of each cell; and  
8        introducing a discharge gas into each cell.

1        49. (Original) The plasma display method of Claim 48, wherein the protective layer  
2 is deposited by one of a thermal chemical vapor deposition step and a plasma enhanced chemical  
3 vapor deposition step.

1        50. (Original) The plasma display method of Claim 49, wherein the discharge gas  
2 includes at least 10% by volume Xe and is at a pressure of at least 500 Torr.

1        51. (Original) The plasma display method of Claim 50, wherein the discharge gas  
2 includes one of Ar and Kr.

1        52. (Amended) The plasma display method of Claim 50, wherein the discharge gas is  
2 selected from a group consisting of Ar-He-Xe, Kr-Ne-Xe, and Kr-He-Xe and the amount of Kr,  
3 Ar, He, or Ne should be in the range of 10% to 50% by volume.

1        53. (Original) The plasma display method of Claim 50, wherein the alkaline earth  
2 compound is selected from the group consisting of magnesium dipivaloyl methane, magnesium  
3 acetylacetone, magnesium trifluoroacetylacetone, and cyclopentadienyl.

1        54. (Original) A method of producing a plasma display panel having a plurality of  
2 discharge space cells comprising the steps of:  
3        depositing a protective layer selected from the group consisting of magnesium  
4 dipivaloyl methane, magnesium acetylacetone, magnesium trifluoroacetylacetone, and  
5 cyclopentadienyl magnesium across a surface of each cell to provide one of a (100) crystal-face  
6 orientation and a (110) crystal-face orientation; and

7           charging each cell with a discharge gas including at least 10% by volume Xe at a  
8 pressure of at least 500 Torr.

1           55. (Original) In a method of producing a plasma display panel having a plurality of  
2 discharge space cells with dielectric layers, the improvement comprising:  
3           evaporating with an electron gun an alkaline earth oxide; and  
4           forming a protective layer of the alkaline earth oxide with (110) crystal-face  
5 orientation on the dielectric layer.

1           56. (Original) The method of Claim 55, wherein the alkaline earth oxide is  
2 magnesium oxide.

1           57. (Original) The method of Claim 55, wherein the temperature of the dielectric  
2 layer was between 250°C and 300°C.

1           58. (Original) In a method of producing a plasma display panel having a plurality of  
2 discharge space cells with dielectric layers, the improvement comprising:  
3           evaporating a metal chelate of alkaline earth oxide in a bubbler;  
4           transferring the evaporated metal chelate of alkaline earth oxide to a reaction  
5 container;  
6           reacting the evaporated metal chelate of alkaline earth oxide with oxygen; and  
7           forming a protective layer of alkaline earth oxide with (100) crystal-face  
8 orientation on the dielectric layer.